

TEC-503

Total No. of printed pages: 1

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<p><b>Odd Semester Examination 2019-20</b>  <b>B.TECH (V SEM)</b>  <b>VLSI TECHNOLOGY-TEC-503</b></p>											
Time : 3:00 hr	Max. Marks : 100										

**Note: Attempt all questions. All question carry equal marks.**

**Q1- Attempt any four of the following:**

**(5x4=20)**

- (a) What are the advantages of Integrated Circuit over discrete components?
- (b) Explain the Fick's Theory of diffusion.
- (c) Discuss CZ technique of crystal growth.
- (d) Discuss the Oxidation process. What is the need of Oxide layer?
- (e) Define the Oxide model for Oxidation process.

**Q2- Attempt any four of the following:**

**(5x4=20)**

- (a) What is Epitaxy? Discuss the types of epitaxy method briefly.
- (b) Explain the difference between Positive and Negative photoresist.
- (c) What is channeling? How does it affect the implantation?
- (d) Describe MBE process. Also write its advantages and disadvantages.
- (e) What is diffusion? Explain different type of diffusion system.

**Q3- Attempt any two of the following:**

**(10x2=20)**

- (a) What is Optical lithography? Explain the printing techniques used in optical lithography.
- (b) Explain the difference between Electron Beam Lithography, Ion beam lithography and X ray lithography. Also define the type of resist used in it.
- (c) Define different types of Etching process. Define the term Uniformity, Anisotropy, Throughput and Selectivity.

**Q4- Attempt any two of the following:**

**(10x2=20)**

- (a) Explain the fabrication steps involved in CMOS IC using p well technology.
- (b) What is metallization and what are the problems associated with it ?
- (c) Explain PVD process. Also explain different types of system used in it.

**Q5- Attempt any two of the following:**

**(10x2=20)**

- (a) What is Packaging? Explain its types.
- (b) What are the parameters considered at the time of packaging?
- (c) Write short note on:-
  - (i) Yield loss in VLSI
  - (ii) Yield loss modeling
  - (iii) Accelerated Testing.